

Docket No.: R2180.0159/P159  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Kazunari Kimino

DO NOT ENTER: /GRK/

07/30/2009

Application No.: 10/609,634

Confirmation No.: 4954

Filed: July 1, 2003

Art Unit: 1791

For: APPARATUS AND METHOD FOR  
MANUFACTURING SEMICONDUCTOR  
DEVICE

Examiner: G. R. Koch

**AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116**

**MS AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Madam:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated May 5, 2009, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 11 of this paper.